



#8/B(U/E)  
12/7/00  
Vivanna  
RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2811

PATENT APPLICATION  
Do. No. 5484-48

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Byung-Sup SHIM et al.

Serial No. 09/305,240

Examiner: O. Nadav

Filed: May 4, 1999

Group Art Unit: 2811

For: **OPEN DRAIN INPUT/OUTPUT STRUCTURE AND MANUFACTURING  
METHOD THEREOF IN SEMICONDUCTOR DEVICE**

Date: November 30, 2000

Box AF  
Assistant Commissioner for Patents  
Washington, D.C. 20231

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TECHNOLOGY CENTER 2800

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116**

Responsive to the final Office Action, dated August 31, 2000, please amend the  
application as follows.

**IN THE SPECIFICATION**

On page 2, line 25, replace "FIG.s" with --FIGs.--;

On page 4, line 9, replace "a n-type" with --an n-type--.

**IN THE CLAIMS:**

Please amend the claim as follows: